

MAY 16 2007

S/N: 10/718,789

5/16/2007

Docket No.: SUG-176-USAP

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/718,789

Confirmation No.: 1591

Applicant: Kazunori HAGIMOTO et al.

Art Unit: 2814

Filed: November 24, 2003

Examiner: Howard Weiss

Docket No: SUG-176-USAP

Customer No: 28892

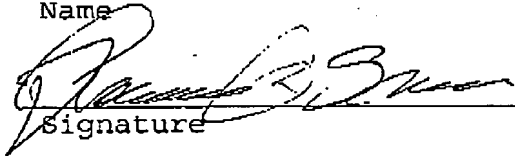
For: Light-Emitting Device, Method of Fabricating the Same, and
OHMIC Electrode Structure for Semiconductor Device

CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence of 2 pages, including this sheet, is being facsimile transmitted to the Patent and Trademark Office Fax No. (571) 273-8300 on May 16, 2007.

RONALD R. SNIDER

Name



Signature

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OHMIC Electrode Structure for Semiconductor Device**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**
PURSUANT TO 37 C.F.R. §§ 1.56, 1.97, and 1.98US Patent & Trademark Office
Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

On May 14, 2007 our office submitted an Information Disclosure Statement in the above captioned case. Inadvertently we failed to mention that this IDS is being filed within three months of the date of the Japanese Office Action from which these documents originate. The date of the Japanese Office Action is April 10, 2007. This matter was discussed with Examiner Howard Weiss on May 15, 2007.

Respectfully submitted,

Ronald R. Snider
Attorney of Record
Reg. No. 24,962Date: May 16, 2007
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